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3/2/02  
Harrison  
026159664

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/233/377  
Filing Date ..... January 18, 1999  
Inventor ..... Gurtej S. Sandhu et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... T. Pham  
Attorney's Docket No. .... MI22-1114  
Title: Method of Forming a Refractory Metal Silicide (as Amended)

**PRELIMINARY AMENDMENT ACCOMPANYING A REQUEST FOR  
CONTINUING EXAMINATION IN RESPONSE TO DECEMBER 19, 2001  
FINAL OFFICE ACTION**

To: Box RCE  
Assistant Commissioner for Patents  
Washington, D.C. 20231

From: Frederick M. Fliegel, Ph.D.  
Tel. 509-624-4276; Fax 509-838-3424  
Wells, St. John, Roberts, Gregory & Matkin P.S.  
601 West First Avenue, Suite 1300  
Spokane, WA 99201-3828

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TECHNOLOGY CENTER 2800

Responsive to the Final Office Action dated December 19, 2001,  
Applicant amends and remarks as follows:

**AMENDMENTS**